

DOCKET NO: 292134US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

:

MASARU SASAKI, ET AL.

: EXAMINER: NIKMANESH, S.J.

SERIAL NO: 10/581,601

:

FILED: JUNE 5, 2006

: GROUP ART UNIT: 2812

FOR: METHOD OF CLEANING
SEMICONDUCTOR SUBSTRATE
CONDUCTIVE LAYER SURFACE

:

AMENDMENT UNDER 37 C.F.R. § 1.111

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated June 10, 2009, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.